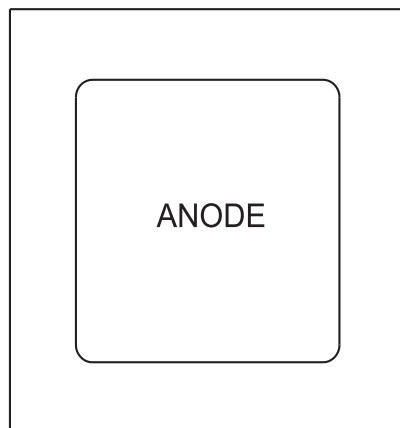


**PROCESS DETAILS**

Process	EPITAXIAL PLANAR
Die Size	14 X 14 MILS
Die Thickness	7.5 MILS
Anode Bonding Pad Area	7.5 X 7.5 MILS
Top Side Metalization	Al - 13,000Å TYP
Back Side Metalization	Au - 14,000Å TYP

**Geometry**



R0

**GROSS DIE PER 4 INCH WAFER**

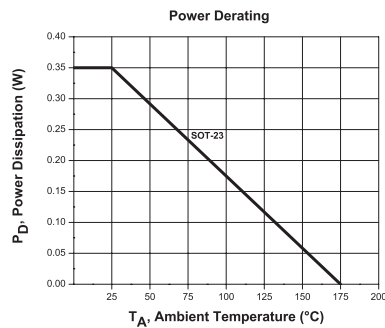
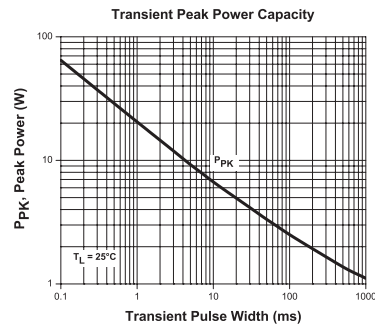
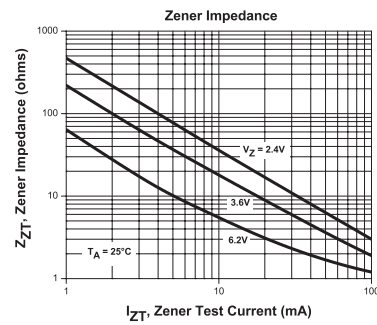
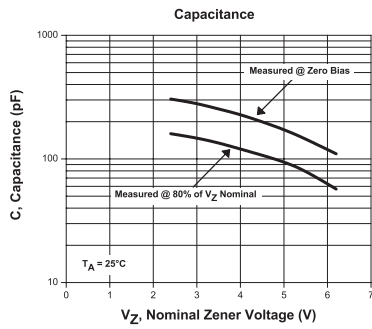
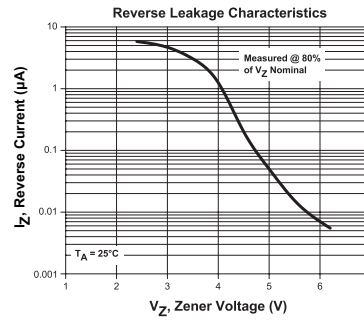
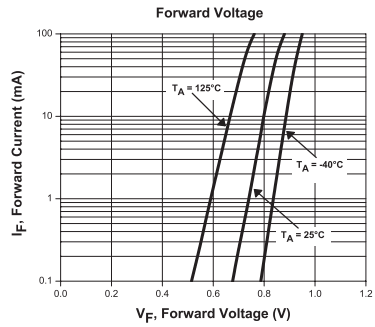
61,141

**PRINCIPAL DEVICE TYPES**

CMPZ5221B  
THRU  
CMPZ5234B

145 Adams Avenue  
Hauppauge, NY 11788 USA  
Tel: (631) 435-1110  
Fax: (631) 435-1824  
www.centalsemi.com

R5 (14-May 2009)



145 Adams Avenue  
Hauppauge, NY 11788 USA  
Tel: (631) 435-1110  
Fax: (631) 435-1824  
www.centralsemi.com

R5 (14-May 2009)